

PATENT Attorney Docket No.: SLM-04300

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Jahja I. Trisnadi

Serial No.: 09/498,703

Filed: February 7, 2000

For:

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

Group Art Unit: 2828

Examiner: Armando Rodriguez

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

METHOD AND APPARATUS FOR )

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Int Commissioner for Patents and one therefore submitted application, and are therefore submitted in the examination of the identified application, and are therefore submitted in the examination of the identified application, and are therefore submitted in the examination of the identified application, and are therefore submitted in the examination of the identified application, and are therefore submitted in the examination of the identified application, and are therefore submitted in the examination of the identified application, and are therefore submitted in the examination of the identified application. above-identified application, and are therefore submitted in compliance with the duty of disclosure defined in 37 C.F.R. §§ 1.56 and 1.97. The Examiner is requested to make these citations of official record in this application.

Applicant has become aware of the following printed publications which may be material to the examination of this application:

U.S. Patent No. 6,323,984 B1.

Attorney Docket No.: PATENT SLM-04300

This Supplemental Information Disclosure Statement under 37 C.F.R. §§ 1.56 and 1.97 is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that anyone or more of these citations constitutes prior art.

Respectfully submitted,

HAVERSTOCK & OWENS LLP

Dated: 1-7-03

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LATIFICATE OF MAILING (37 CFR \$ 1.8(a),

hereby certify that this paper (along with any eferred to as being attached or enclosed) is being teposited with the U.S. Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the: Assistant Commissioner for Patents, Washington D.C. 20231

HAVERSTOCK & OWENS LLP.

ate: 1/7/03 By: Shun OMCumick